

UNITED STATES PATENT AND TRADEMARK OFFICE

2A
on
7/8/02

APPLICANT(S) Joseph Louis Petrucci, Jr.

GROUP ART

UNIT: Unknown

APPLN. NO.:

EXAMINER: Unknown

FILED: Concurrently Herewith

TITLE: METHOD AND SYSTEM FOR DETERMINING A
PERFORMANCE OF PLASMA ETCH EQUIPMENT

Certificate of Mailing

Date of deposit: 12.21.01

I hereby certify that this paper is being deposited with the United States Postal Service on the date indicated above, as first-class mail, with sufficient postage attached thereto, in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C.

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PRELIMINARY AMENDMENT

Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

Please enter this Preliminary Amendment in the above-
entitled Application.